

	Application/Control No.	Applicant(s)/Patent under Reexamination	
	09/676,598	OPEROWSKY ET AL.	
ĺ	Examiner	Art Unit	
	John A. Tweel, Jr.	2636	

SEARCHED					
Class	Subclass	Date	Examiner		
340	425.5	12/22/2005	JAT		
	988				
	980				
	990				
	995.1				
	995.2				
345	7	12/22/2005	JAT		
701	201				
	208				
	213	12/22/2005	JAT		

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
	<u> </u>				

SÉARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
		<u> </u>	